

Electronic Patent Application Fee Transmittal

Application Number:	10799910			
Filing Date:	12-Mar-2004			
Title of Invention:	ION IMPLANTATION OF HIGH-K MATERIALS IN SEMICONDUCTOR DEVICES			
First Named Inventor/Applicant Name:	Hong-Jyh Li			
Filer:	Steven Edward Dicke/Katy Henry			
Attorney Docket Number:	2004P50029US/I331.135.101			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	1402	1	500	500
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				500